



FFW

Atty. Dkt. No. 039262-0115

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Tadahiro OHMI et al.

Title: SEMICONDUCTOR DEVICE AND METHOD OF  
MANUFACTURING THE SAME

Appl. No.: 10/725,063

Filing Date: December 2, 2003

Examiner: Remmon R. Forde

Art Unit: 2826

**RESPONSE TO RESTRICTION/ELECTION REQUIREMENT**

Mail Stop NON-FEE AMENDMENT  
Commissioner for Patents  
PO Box 1450  
Alexandria, Virginia 22313-1450

Sir:

In response to the Office Action dated January 4, 2005, Applicants hereby elect Group II (Claims 25-76), drawn to a method of making a semiconductor device, for prosecution in the subject application, in order to advance the prosecution of this application.

Applicants, of course, reserve the right to file a divisional application covering the subject matter of the non-elected claims.

Receipt of the initial Office Action on the merits is awaited.

Respectfully submitted,

Date: January 28, 2005

FOLEY & LARDNER, LLP  
Customer Number: 22428  
Telephone: (202) 672-5300  
Facsimile: (202) 672-5399

By Phillip J. Articola  
Phillip J. Articola  
Attorney for Applicant  
Registration No. 38,319